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Docket: 0756-2119

JC674 U.S. PTO
09/550598
04/17/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL Application of)
Hisashi OHTANI et al.)
Based On Serial No. 09/197,767) Art Unit: 2814
Which Was Filed: November 23, 1998) Examiner: P. Cao
For: SEMICONDUCTOR DEVICE AND)
PROCESS FOR PRODUCING THE)
SAME) Date: April 17, 2000

INFORMATION DISCLOSURE STATEMENT
AND NOTIFICATION OF RELATED APPLICATION

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/197,767 filed November 23, 1998.

The attention of the Examiner is directed to related application Serial No. 08/794,879. Copies of U.S. Patent Nos. 5,562,529; 5,567,300; 5,575,706; 5,658,806; 5,616,934; and 5,807,165 are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,



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